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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
(Case No. 207.008-US)

In the Application of: Lutz et al.

Serial No: 10/627,237

Filed: July 25, 2003

Title: Anchors for Microelectromechanical Systems
Having an SOI Substrate, and Method for
Fabricating SameCommissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

) Group Art Unit: 2822

) Examiner: Prenty, Mark V.

I hereby certify that this correspondence
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Patents, P.O. Box 1450, Alexandria, VA
22313-1450 on March 3, 2005

Michiko Siter Date
(person signing this certificate)

Michiko Siter
Signature

SIXTH INFORMATION DISCLOSURE STATEMENT

Dear Sir:

Submitted herewith are two (2) sheets of a modified Form PTO-1449. Electronic copies of the U.S. patents and published U.S. patent applications identified on the attached Form PTO-1449 are found on the attached compact disc ("CD"). A paper copy of each foreign document and publication cited on the attached Form PTO-1449 is also submitted.

Notably, U.S. Published Patent Application 2004-0065932 is the U.S. counterpart of International Application No. WO 01/46066, both of which are identified in the attached Form PTO-1449. That published application was cited in U.S. Patent Application Serial No. 10/455,555, entitled "Microelectromechanical Systems having Trench Isolated Contacts, and Methods for Fabricating Same".

It is respectfully requested that the Examiner make his/her consideration of these documents formally of record with the next Office Action.

Respectfully submitted,

Date: March 3, 2005

Neil A. Steinberg
Neil A. Steinberg, Reg. No. 34,735
Telephone No. 650-968-8079

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PTO-1449 (Modified) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE INFORMATION DISCLOSURE STATEMENT BY APPLICANT	ATTY. DOCKET NO.	SERIAL NUMBER
	207.008-US	10/627,237
	APPLICANT(S)	
	Lutz et al.	
	FILING DATE	GROUP ART UNIT
	July 25, 2003	2822

Sheet 1 of 2

U.S. PATENT DOCUMENTS

EXAMINER INITIALS	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE
	4,849,071	7/1989	Evans et al.			
	4,945,769	8/1990	Sidner et al.			
	5,445,991	8/1995	Lee			
	5,470,797	11/1995	Mastrangelo			
	5,816,514	4/1997	Muchow et al.			
	6,521,508	2/2003	Cheong et al.			
	2004/0016989	1/2004	Ma et al.			
	6,621,134	9/2003	Zum			
	4,865,610	5/1987	Barth			
	4,768,866	8/1998	Sugiyama et al.			
	5,139,624	8/1992	Searson et al.			
	5,338,416	8/1994	Mlcak et al.			
	6,808,954	10/2004	Ma et al.			
	2004-0065932	4/2004	Reichenbach et al.			

FOREIGN PATENT DOCUMENTS

EXAMINER INITIALS	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	TRANSLATION YES/NO

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER	DATE CONSIDERED
EXAMINER: Initial citation if reference was considered. Draw line through citation if not in conformance to MPEP 609 and not considered. Include copy of this form with next communication to applicant.	

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Sheet 2 of 2

PTO-1449 (Modified) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE INFORMATION DISCLOSURE STATEMENT BY APPLICANT	ATTY. DOCKET NO. 207.008-US	SERIAL NUMBER 10/627,237
	APPLICANT(S) Lutz et al.	
	FILING DATE July 25, 2003	GROUP ART UNIT 2822

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EXAMINER INITIALS	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE

FOREIGN PATENT DOCUMENTS

EXAMINER INITIALS	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	TRANSLATION TEXT
	WO 01/48068	6/2001	PCT			
	GB 2 198 611	6/1988	Great Britain			
	WO 97/49475	12/1997	PCT			
	EP 0 451 992	10/1991	European			

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

	"Permeable Polysilicon Etch-Access Windows for Microshell Fabrication", Leboutz K S et al., International Conference on Solid-State Sensors and Actuators and Eurosensors, 25 June 1995 (1998-06-25), pp. 224-227
	"Porous Polycrystalline Silicon: A New Material for MEMS", Anderson R C et al., Journal of Microelectromechanical Systems, March 1994, USA, vol. 3, no. 1, pp.10-18
	"Vacuum Encapsulation of Resonant Devices Using Permeable Polysilicon", Leboutz et al., 1999 IEEE, pp.470-475
	"Laterally Grown Porous Polycrystalline Silicon: A New Material for Transducer Applications", Anderson et al., 1991 IEEE, pp.747-750

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P.O. Box 1450
Alexandria, VA 22313-1450) Group Art Unit: **2822**) Examiner: **Prenty, Mark V.**

I hereby certify that this correspondence
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United States Patent and Trademark
Office, Fax No. (703) 872-9306 on

March 25, 2005

Date

Michiko Sites

(name of person signing certificate)

Michiko Sites

Signature

SEVENTH INFORMATION DISCLOSURE STATEMENT

Dear Sir:

Submitted herewith is one (1) sheet of a modified Form PTO-1449. The U.S. patents listed on the modified Form PTO-1449 are not attached hereto. (See, 37 C.F.R. §1.98(a)(2)). Should the Examiner desire a copy of the documents, kindly contact the undersigned.

Kindly note, the references identified on the attached Form PTO-1449 were cited on the International Search Report (copy attached) corresponding to the related PCT application.

It is respectfully requested that the Examiner make his/her consideration of these documents formally of record with the next Office Action.

Respectfully submitted,

Neil A. Steinberg, Reg. No. 34,735
Telephone No. 650-968-8079

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Sheet 1 of 2

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	207.008-US	10/827,237
	APPLICANT(S) Lutz et al.	
	FILING DATE July 23, 2003	GROUP ART UNIT 2822

U.S. PATENT DOCUMENTS

EXAMINER INITIALS	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE
	5,576,250	11/1998	Diem et al.			
	6,048,774	4/2000	Yamamoto et al.			
	6,240,782	6/2001	Kato et al.			

FOREIGN PATENT DOCUMENTS

EXAMINER INITIALS	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	TRANSLATION YES/NO

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